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		Application Number	<b>10/529,369</b>		
		Filing Date	<b>October 5, 2005</b>		
		First Named Inventor	<b>H. MATSUTANI</b>		
		Art Unit	<b>1796</b>		
Examiner Name	<b>Marc S. Zimmer</b>				
Sheet	<b>1</b>	of	<b>1</b>	Attorney Docket Number	<b>1303.44954X00</b>

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)				
		US-				
		US-				
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FOREIGN PATENT DOCUMENTS							
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)					
		JP 2001-338978		12/07/2001	K. Furusawa, et al.		A
		JP 06-346025		12/20/1994	Y. Yamaho, et al.		A
		JP 2001-15496		01/19/2001	M. Tsunoda, et al.		A

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		Japanese Official Action dated May 12, 2009, for Japanese Application No. 2003-317572.	
		Japanese Official Action dated April 28, 2009, for Japanese Application No. 2003-317568.	
		Y. Uchimar, et al., "Synthesis, Thin Film Formation and Evaluation of a Low-K Silicon-Borazine Polymer", <u>Polymer Preprints</u> , Vol. 51, No. 12 (2002), pp.3077-3078.	T
		H. Kame, "AIST has Developed Low-K Films Using Borazine-Silicon Polymer Material to Demonstrate Low Permittivity of 2.1 or Below", <u>Technology Semiconductor</u> , (2002), pp. 100-101.	T

Examiner Signature		Date Considered	
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